



Applicant: Masatomo SHIBATA
Title: III-V GROUP NITRIDE SYSTEM SEMICONDUCTOR
SUBSTRATE
Application No.: 10/752,092
Filing Date: 01/07/2004
Examiner: David S. Blum
Art Unit: 2813

AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated July 25, 2005, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 5 of this document.

Please amend the application as follows: